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Title of Invention:	Plasma apparatus and method capable of adaptive impedance matching				
First Named Inventor:	Chien-Hsin Lai				
Correspondence Address:	LOWE HAUPTMAN GILMAN & BERNER, LLP - Suite 310 1700 Diagonal Road Alexandria VA 22314 US 7036841111				
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Document Number	Document Description	File Name	File Size(Bytes)	Multi Part	Pages
1	Amendment After Final	20060818ResponsetoFinal.p df	54425	no	7
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National Stage of an International Application under 35 U.S.C. 371

If a timely submission to enter the national stage of an international application is compliant with the conditions of 35 U.S.C. 371 and other applicable requirements a Form PCT/DO/EO/903 indicating acceptance of the application as a national stage submission under 35 U.S.C. 371 will be issued in addition to the Filing Receipt, in due course.